

# 11) Prior  
ABST  
10/11/02  
VLS

Inventor: Garry A. Mercaldi  
Title: Low Selectivity Deposition Methods  
Assignee: Micron Technology, Inc.  
Serial No.: 09/643,004  
Filing Date: August 21, 2000

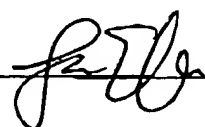
**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to Application No. 09/652,533 listed on the attached Form PTO-1449, a copy of the February 22, 2002 amendment is attached. No admission is made regarding whether the submitted references are prior art. No fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 26 Sep 2002

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